

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Shigenobu MAEDA

SERIAL NO: NEW APPLICATION

GAU:

FILED: HEREWITH

EXAMINER:

FOR: SEMICONDUCTOR DEVICE, TERMINAL DEVICE AND COMMUNICATION METHOD

**INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97**

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:

Applicant(s) wish to disclose the following information.

**REFERENCES**

The applicant(s) wish to make of record the references listed on the attached form PTO-1449. Copies of the listed references were submitted in prior application Serial No. 09/943,026 filed August 31, 2001, where required, as are either statements of relevancy or any readily available English translations of pertinent portions of any non-English language references.

A check is attached in the amount required under 37 CFR §1.17(p).

**RELATED CASES**

Attached is a list of applicant's pending application(s) or issued patent(s) which may be related to the present application. A copy of the patent(s), together with a copy of the claims and drawings of the pending application(s) is attached along with PTO 1449.

A check is attached in the amount required under 37 CFR §1.17(p).

**CERTIFICATION**

Each item of information contained in this information disclosure statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.

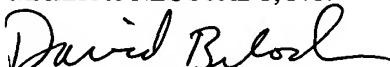
No item of information contained in this information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application or, to the knowledge of the undersigned, having made reasonable inquiry, was known to any individual designated in 37 CFR §1.56(c) more than three months prior to the filing of this statement.

**DEPOSIT ACCOUNT**

Please charge any additional fees for the papers being filed herewith and for which no check is enclosed herewith, or credit any overpayment to deposit account number 15-0030. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,  
MAIER & NEUSTADT, P.C.



Gregory J. Maier

Registration No. 25,599



22850

Tel. (703) 413-3000  
Fax. (703) 413-2220  
(OSMMN 05/03)

David A. Bilodeau  
Registration No. 42,325

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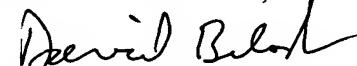
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Form PTO 1449 (Modified)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY DOCKET NO. 239307US-2 CONT		SERIAL NO. NEW APPLICATION	
LIST OF REFERENCES CITED BY APPLICANT		APPLICANT		Shigenobu MAEDA			
		FILING DATE HEREWITH		GROUP			
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
	AM						
	AN						
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION		
					YES	NO	
	AO	6-326315	11/25/94	JAPAN			X
	AP	8-293611	11/05/96	JAPAN			X
	AQ	7-99207	04/11/95	JAPAN			X
	AR	61-1900	01/21/86	JAPAN			X
	AS						
	AT						
	AU						
	AV						
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)							
	AW	"GSM (Global System for Mobile Communication)", NIKKEI ELECTRONICS (No. 736), February 8, 1999, pgs. 155-162					
	AX	Shigenobu MAEDA, et al., "An Analytical Method of Evaluating Variation of the Threshold Voltage Shift Caused by the Negative-Bias Temperature Stress in Poly-Si TFT's" IEEE TRANSACTIONS ON ELECTRON DEVICES, VOL. 45, NO. 1, January 1998, pgs. 165-172					
	AY	S. MAEDA, et al., "Mechanism of Negative-Bias Temperature Instability in Polycrystalline-silicon Thin Film Transistors", JOURNAL OF APPLIED PHYSICS, VOL. 76, NO. 12, December 15, 1994, pgs. 8160-8166					
	AZ	Yasuo KADOKAWA, "Spectrum Kakusan Tsushin Gijutsu: Saishin Oyo Report-Shu", Nihon Gijutsu Keizai Center, January 30, 1987, pgs 3-24					
Examiner					Date Considered		
*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

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				FILING DATE HEREWITH		GROUP	
<b>U.S. PATENT DOCUMENTS</b>							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
AA		4,969,126	11/06/90	MAENO			
AB		5,903,043	05/11/99	ICHIKAWA ET AL.			
AC		5,789,763	08/04/98	KATO ET AL.			
AD		6,037,923	03/14/00	SUZUKI			
AE							
AF							
AG							
AH							
AI							
AJ							
AK							
AL							
AM							
AN							
<b>FOREIGN PATENT DOCUMENTS</b>							
		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION		
AO		WO 00/49538	08/24/00	WIPO	XX		
AP		408320832	12/96	JAPAN	XX		
AD							
AR							
AS							
AT							
AU							
AV							
<b>OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)</b>							
	AW						
	AX						
	AY						
	AZ					<input type="checkbox"/> Additional References sheet(s) attached	
Examiner				Date Considered			

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